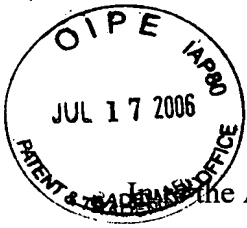


AF  
IFW**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Reply, Please Refer to the Application of

Tae-wan KIM et al.

Art Unit: 1763

Serial No. 10/748,277

Examiner: L.L. Alejandro Mulero

Filed: December 31, 2003

Confirmation No. 6602

For: INDUCTIVELY COUPLED ANTENNA AND  
PLASMA PROCESSING APPARATUS  
USING THE SAME

Attorney Docket No. 249/409

**REPLY UNDER 37 C.F.R. § 1.116**Mail Stop **BOX AF**  
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Alexandria, VA 22313-1450

Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action Made Final dated May 17, 2006, the following amendments and remarks are respectfully submitted in connection with the above-identified application:

**A Listing of the Claims** begins on page 2 of this paper; and**Remarks** begin on page 6 of this paper.